PATENT H1902/AMDP981US

CERTIFICATE OF TRANSMISSION

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Date: June 7, 2006 /Christina M. Padamonsky/
Christina M. Padamonsky

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Applicant(s): Gilles Amblard, et al. Examiner: Daborah Chacko-Davis

Serial No: 10/645,364 Art Unit: 1756

Filing Date: August 21, 2003

Title: COMBINATION OF NON-LITHOGRAPHIC SHRINK TECHNIQUES AND TRIM PROCESS FOR GATE FORMATION AND LINE-EDGE ROUGHNESS REDUCTION

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

REPLY TO FINAL OFFICE ACTION DATED APRIL 19, 2006

Dear Sir:

Favorable reconsideration of the above-identified patent application is respectfully requested in view of the following comments.